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**Bib Data Sheet** 

**CONFIRMATION NO. 5486** 

SERIAL NUMBE 10/565,108	FILING OR 371(c) DATE 01/19/2006 RULE	CLASS 117		GROUP ART UNIT		ATTORNEY DOCKET NO. 126623		
** CONTINUING D. This applicat ** FOREIGN APPL JAPAN 2003	ion is a 371 of PCT/JP04/(							
** 04/28/2006  Foreign Priority claimed 35 USC 119 (a-d) condit met  Verified and Acknowledged  ADDRESS 25944		SHEETS DRAWING 3	AWING CLAIMS		INDEPENDENT CLAIMS 1			
TITLE Method for producin	ng silicon wafer and silicon	wafer						
RECEIVED No	ES: Authority has been giv to charge/cre for following:	S: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following:			All Fees  1.16 Fees ( Filing )  1.17 Fees ( Processing Ext. of time )  1.18 Fees ( Issue )  Other  Credit			